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## AMENDMENT TRANSMITTAL LETTER

Docket No.  
0171-1022P

Application No.	Filing Date	Examiner	Art Unit
10/671,732-Conf. #6775	September 29, 2003	S. J. Lee	1752

Applicant(s): Takeshi KINSHO et al.

Invention: POLYMERIZABLE SILICON-CONTAINING COMPOUND, MANUFACTURING METHOD,  
POLYMER, RESIST COMPOSITION AND PATTERNING PROCESS

**MS Amendment**  
**Commissioner for Patents**  
**P.O. Box 1450**  
**Alexandria, VA 22313-1450**

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	16	- 20 =		X	
Independent Claims	7	- 7 =		X	
Multiple Dependent Claims (check if applicable)					<input type="checkbox"/>
Other fee (please specify):					
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>					0.00

Large Entity

Small Entity

No additional fee is required for this amendment.

Please charge Deposit Account No. \_\_\_\_\_ in the amount of \$ \_\_\_\_\_.  
A duplicate copy of this sheet is enclosed.

A check in the amount of \$ \_\_\_\_\_ is enclosed.

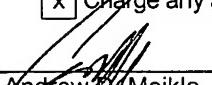
Payment by credit card. Form PTO-2038 is attached.

The Director is hereby authorized to charge and credit Deposit Account No. 02-2448  
as described below. A duplicate copy of this sheet is enclosed.

Credit any overpayment.

Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.

Dated: April 24, 2006

  
Andrew W. Meikle

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Docket No.: 0171-1022P  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Takeshi KINSHO et al.

Application No.: 10/671,732

Confirmation No.: 6775

Filed: September 29, 2003

Art Unit: 1752

For: POLYMERIZABLE SILICON-CONTAINING  
COMPOUND, MANUFACTURING METHOD,  
POLYMER, RESIST COMPOSITION AND  
PATTERNING PROCESS

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Examiner: S. J. Lee

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated January 24, 2006, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 11 of this paper.